

Docket No.: 50103-537

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
Nobuo KURATAKA, et al. :  
Serial No.: : Group Art Unit:  
Filed: June 25, 2003 : Examiner:  
For: METHOD FOR PROTECTING SURFACE OF STAMPER/IMPRINTER DURING  
MANUFACTURE THEREOF

**CLAIM OF PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**United States Provisional Patent Application No. 60/393,573, filed July 1, 2002**

Respectfully submitted,

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**Date: June 25, 2003**